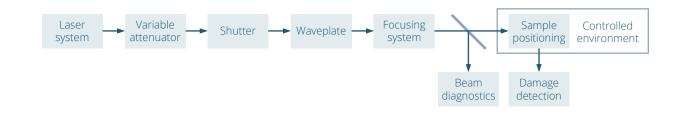


## TEST EQUIPMENT

#### Test setup



### Laser and its parameters

Q-switched, seeded Nd:YAG Type

Manufacturer InnoLas Laser II Model

SpitLight Hybrid Central wavelength 1064.0 nm

Angle of incidence 0.0 deg Polarization state Linear Pulse repetition frequency 100 Hz

Spatial beam profile in target plane TEM00

Beam diameter in target plane  $(1/e^2)$  $(225.3 \pm 3.4) \, \mu m$ Longitudinal pulse profile Single longitudinal mode

Pulse duration (FWHM)  $(9.9 \pm 0.3) \text{ ns}$ 0.8 %

Pulse to pulse energy stability (SD)

#### Energy/power meter

Manufacturer Ophir Model PE50-DIF-C Calibration due date 2022-05-01

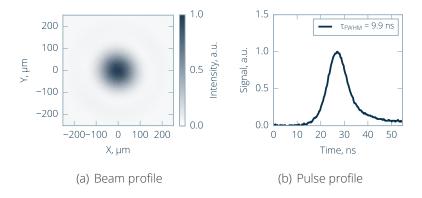


Figure 1. Laser parameters used for measurements.



## **TEST SPECIFICATION**

### Definitions and test description

Laser-induced damage (LID) is defined as any permanent laser radiation induced change in the characteristics of the surface/bulk of the specimen which can be observed by an inspection technique and at a sensitivity related to the intended operation of the product concerned. Laser-induced damage threshold (LIDT) is defined as the highest quantity of laser radiation incident upon the optical component for which the extrapolated probability of damage is zero.

LID of the sample is investigated by performing a standardized S-on-1 test procedure.<sup>2</sup> LIDT value is determined by fitting experimental damage probability data with a model derived for a Poisson damage process assuming degenerate defect ensemble.<sup>3</sup>

420 Hexagonal
900 μm
1000
Scattered light diode
Nomarski microscope
5b02bef
Air
ISO7
1 bar
21.4 - 21.6 C
39.8 - 39.9 %
Normal laboratory conditions
Canned air
Isopropanol

<sup>&</sup>lt;sup>1</sup>ISO 21254-1:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 1: Definitions and general principles, International Organization for Standardization, Geneva, Switzerland (2011)

<sup>&</sup>lt;sup>2</sup>ISO 21254-2:2011: Lasers and laser-related equipment - Test methods for laser-induced damage threshold - Part 2: Threshold determination, International Organization for Standardization, Geneva, Switzerland (2011)

<sup>&</sup>lt;sup>3</sup>J. Porteus and S. Seitel, Absolute onset of optical surface damage using distributed defect ensembles, Applied Optics, 23(21), 3796–3805 (1984)



## LIDT TEST RESULTS

## LIDT VALUE

10<sup>3</sup>-on-1 115.8  $^{+4.3}_{-8.2}$  J/cm<sup>2</sup>

## CHARACTERISTIC DAMAGE CURVE

Table 1: Estimated LIDTs from fiting model for sample M001948 LOT0082540.

Test mode	Threshold (Offline detection - microscopy)	Threshold (Online detection - scattering)
1-on-1	115.8 <sup>+5.6</sup> <sub>-8.2</sub> J/cm <sup>2</sup>	115.8 <sup>+6.6</sup> J/cm <sup>2</sup>
10-on-1	-	115.8 <sup>+6.6</sup> J/cm <sup>2</sup>
10 <sup>2</sup> -on-1	-	115.8 <sup>+5.1</sup> <sub>-7.9</sub> J/cm <sup>2</sup>
10 <sup>3</sup> -on-1	115.8 <sup>+4.3</sup> <sub>-8.2</sub> J/cm <sup>2</sup>	115.8 <sup>+4.1</sup> J/cm <sup>2</sup>

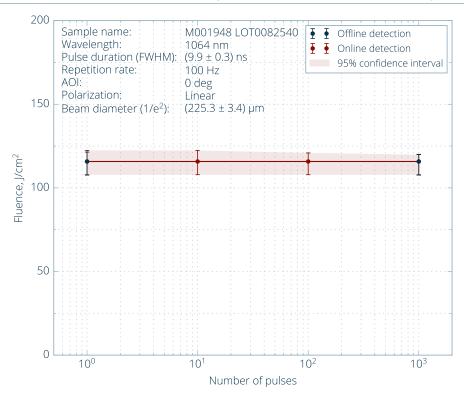


Figure 2. Characteristic damage curve.



# DAMAGE PROBABILITY (OFFLINE DETECTION)

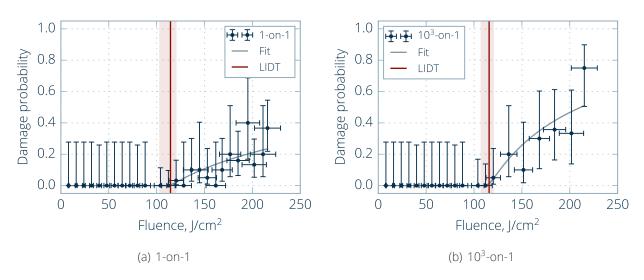


Figure 3. Damage probability plots.



# TYPICAL DAMAGE MORPHOLOGY (OFFLINE DETECTION)

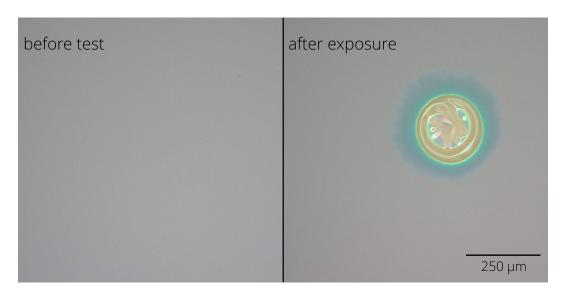


Figure 4. Typical damage morphology: fluence 122 J/cm<sup>2</sup>, damage after 1 pulse(s).

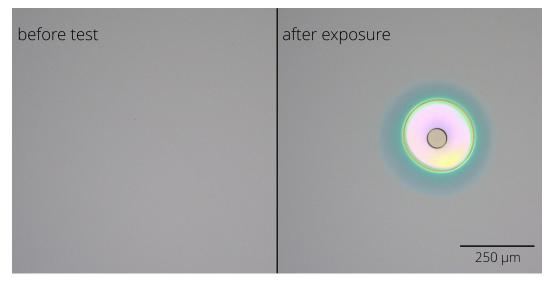


Figure 5. Typical damage morphology: fluence 149 J/cm<sup>2</sup>, damage after 1 pulse(s).



# DAMAGE PROBABILITY (ONLINE DETECTION)

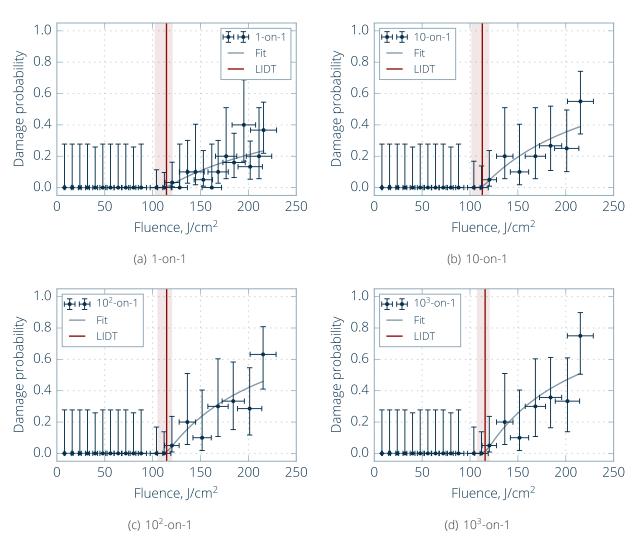


Figure 6. Damage probability plots.